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RESPONSE UNDER 37 CFR SECTION 1.116
EXPEDITED PROCEDURE - GROUP 1765

Patent
10007744-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Simon Dodd

Application No.: 09/932,055

Filed: August 16, 2001

For: THERMAL INKJET PRINTHEAD
PROCESSING WITH SILICON
ETCHING

Examiner: Lynette T. Umez-Eronini

Group Art Unit: 1765

AMENDMENT AND RESPONSE TO FINAL ACTION

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Action of January 10, 2005, please amend the above-identified application as follows:

Enter Amendment

L. J. U-E.

3/10/2005